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Serial Number: 10719242

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Inventor Information for 10/719242

Inventor Name	City	State/Country
BURLESON, MICHAEL	ARLINGTON	TEXAS

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US 20040150255 A1	US- PGPUB	20040805	17	Rotatable safety seatback for recreational vehicles	297/215.12		Burleson, Michael Allan
US 6994396 B2	USPAT	20060207		Rotatable safety seatback for recreational vehicles	297/215.12	114/362; 114/363; 297/215.11; 297/353	Burleson; Michael Allan
US 6607423 B1	USPAT	20030819	21	Method for achieving a desired semiconductor wafer surface profile via selective polishing pad conditioning	451/8	451/21; 451/41; 451/56; 451/72	Arcayan; Rigel G. et al.
US 6309277 B1	USPAT	20011030		System and method for achieving a desired semiconductor wafer surface profile via selective polishing pad conditioning	451/8	451/10; 451/21; 451/72	Arcayan; Rigel G. et al.